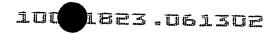


Appendix A

(deletions are bracketed and insertions are underlined)

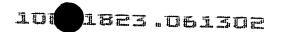
IN THE CLAIMS:

- 1 3. (Amended) A probe card as claimed in claim 1 [or claim 2], wherein said contactor is
- 2 extended to a predetermined direction from a surface of said substrate.
- 4. (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 3], wherein said
- 2 contactor has a vertical elasticity against a surface of said substrate.
- 5. (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 4], wherein at least
- a portion of said signal transmission path near said end of it is made of the same amorphous
- 3 material used for said contactor.
- 6. (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 5] further
- 2 comprising a grounding line, which is grounded, formed to be apart from and in parallel to
- 3 said signal transmission path.
- 1 7. (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 6] further
- 2 comprising a low-resistance unit having lower resistance than that of said signal transmission
- 3 path, said low-resistance unit being formed near said signal transmission path.
- 8. (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 7], wherein said
- 2 contactor comprises a contacting point made of a contact-point material on an end of it.
- 9. (Amended) A probe as claimed in [any one of] claim[s] 1 [to 8], wherein said
- 2 contactor is coated with a metal material.



U.S. PATENT APPLICATION NO. ATTORNEY DOCKET NO.: 02008.073001

- 1 10. (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 9] further
- 2 comprising a voltage providing unit for providing a predetermined voltage, said voltage
- providing unit being provided on a backside of said one side of said substrate.
- 1 13 (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 12] further
- 2 comprising a plurality of contactors made of an amorphous material having a supercooled
- 3 liquid phase region, wherein said plurality of contactors are electrically coupled to said
- 4 contactors formed on said one side of said substrate through said signal transmission paths
- and formed on [said] a backside of said substrate.
- 1 16. (Amended) A method for forming a contactor as claimed in claim 14 [or 15], wherein
- 2 said amorphous material layer is formed by sputtering said amorphous material.
- 1 17. (Amended) A method for forming a contactor as claimed in [any one of] claim[s] 14
- 2 [to 16], wherein said step for forming said contactor comprises a step for causing a plastic
- deformation of said free unit toward a predetermined direction from said substrate.
- 1 18. (Amended) A method for forming a contactor as claimed in [any one of] claim[s] 14
- 2 [to 17], wherein said step for forming said contactor comprises a step for heating said free
- 3 unit.
- 1 19. (Amended) A method for forming a contactor as claimed in [any one of] claim[s] 14
- 2 [to 18], wherein said step for forming said contactor comprises a step for providing a bending
- adjustor at a predetermined position toward a direction of gravity from [said] a surface of said
- 4 substrate.



U.S. PATENT APPLICATION NO. ATTORNEY DOCKET NO.: 02008.073001

- 1 21. (Amended) A method for forming a contactor as claimed in [any one of] claim[s] 14
- 2 [to 18], wherein said step for forming said contactor comprises a step for providing a bending
- 3 adjusting member comprising an engaging unit for suppressing movement of said substrate in
- 4 a direction of gravity and a bending adjustor for determining said predetermined position
- toward a direction of gravity from [said] a surface of said substrate.